

Notice of References Cited		Application/Control No.	Applicant(s)/Patent Under Reexamination ANANDAN ET AL.	
		Examiner Mike Qi	Art Unit 2871	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2002/0094806 A1	07-2002	Kamimura, Sawa	455/415
*	B	US-6,690,955 B1	02-2004	Komiyama, Takehiko	455/566
*	C	US-2004/0119755 A1	06-2004	Guibourge, Nicolas	345/827
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP 2000-358086	12-2000	Japan	-	H04M 1/00
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.